

FIG. 1B

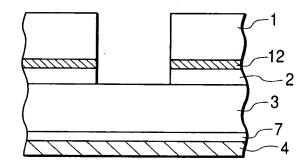


FIG. 1C

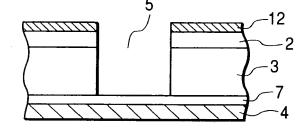


FIG. 1D

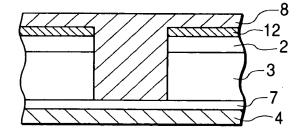
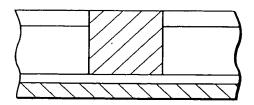
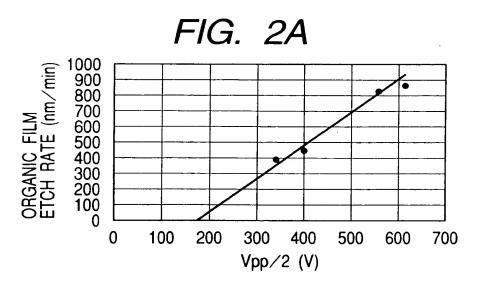
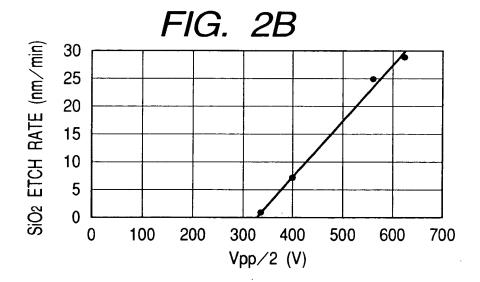


FIG. 1E





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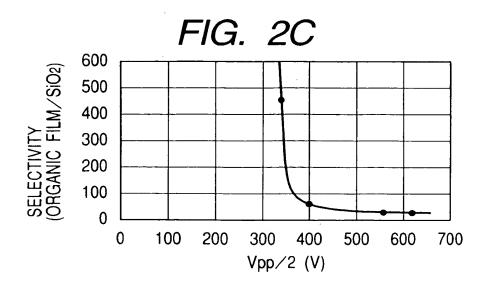


FIG. 3

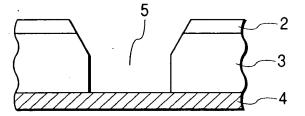
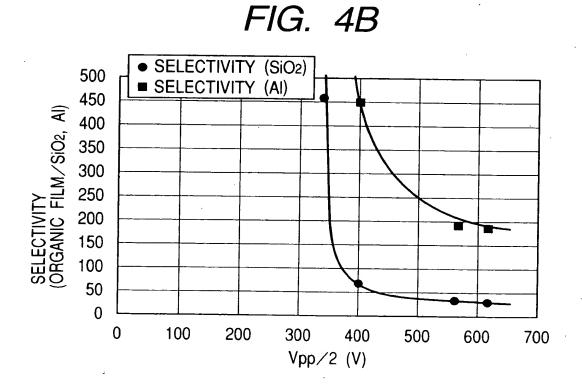


FIG. 4A SiO<sub>2</sub> E/R AI E/R ETCH RATE (nm/min) Vpp/2 (V)



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FIG. 5A

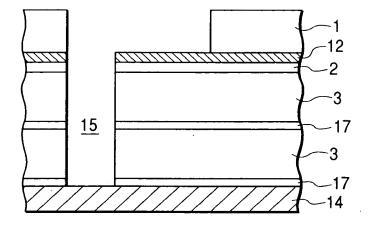


FIG. 5B

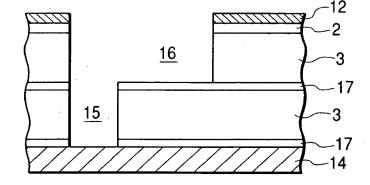
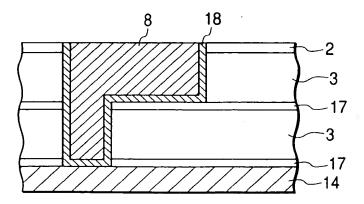


FIG. 5C





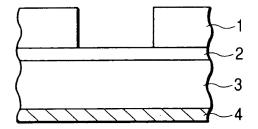


FIG. 6B

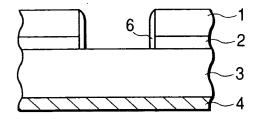


FIG. 6C

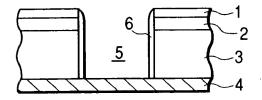
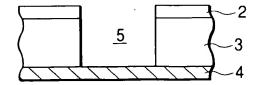


FIG. 6D



## FIG. 7

n: POSITIVE INTEGER

R: ALKYL GROUP

## FIG. 8

n: POSITIVE INTEGER

R: ALKYL GROUP